Refine Search

Search Results -

Terms	Documents
L7 and L3	41

Database:

US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
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Derwent World Patents Index
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Search: L8

[Refine Search]

[Recall Text]   [Clear]   [Interrupt]

Search History

DATE: Wednesday, March 17, 2004   Printable Copy   Create Case

Set Name side by side	Query	Hit Count	Set Name result set
DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ			
L8	L7 and l3	41	L8
L7	L6 or l5 or l6	86871	L7
L6	55/$.ccls.	44515	L6
L5	454/$.ccls.	44708	L5
L4	438/$.ccls.	152613	L4
L3	L2 and (air near4 (ducts or sections))	125	L3
L2	L1 and (second or post) near5 (clean$ or ventilat$)	803	L2
L1	clean room and semiconductor	8480	L1

END OF SEARCH HISTORY